



Challenges of Obtaining of Ultra-High Vacuum in NICA Project

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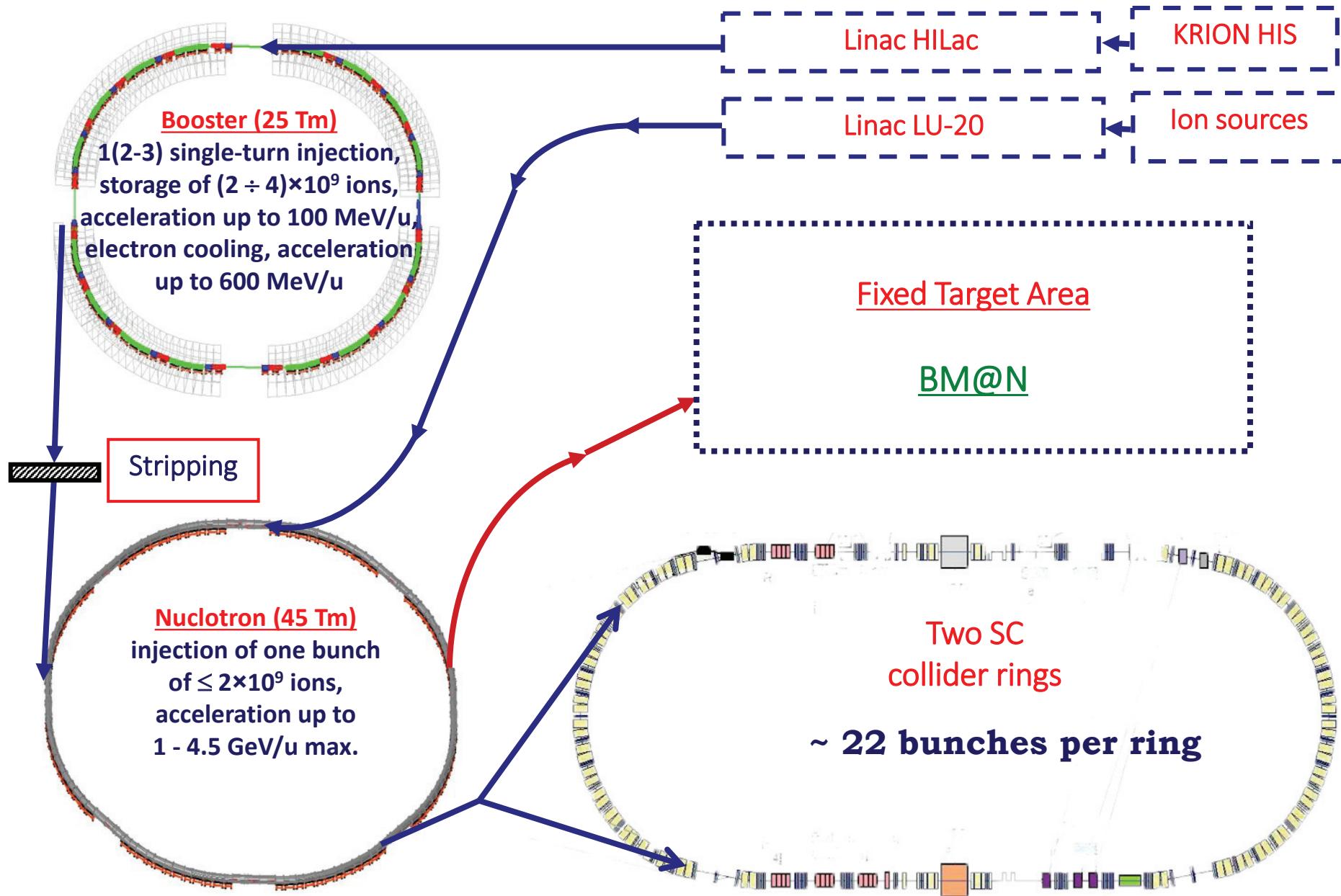
RuPAC'18, Protvino

04/10/2018

Key points to obtaining of ultra-high vacuum

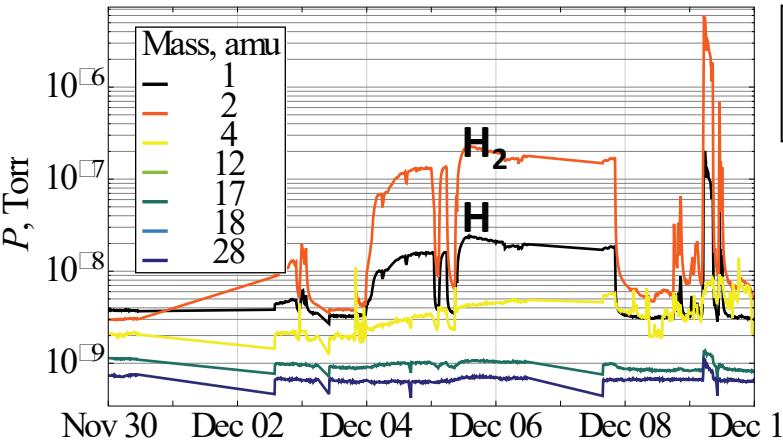
- More than 90% of rest gas should be hydrogen
- Definition of total outgassing flow and gas flow per square
- Dry (without oil) pumping systems (turbo, forevacuum pumps)
- Combination of ion pumps with TSP, NEG, Cryo pumps
- Baking after assembling to remove water
- Beam lifetime due to losses on rest gas
- NEG coating for long beam pipes under room temperature
- Dynamics vacuum instability for high intensity beams
- Electron cloud instability – special treatment of the surface

NICA Accelerator Complex



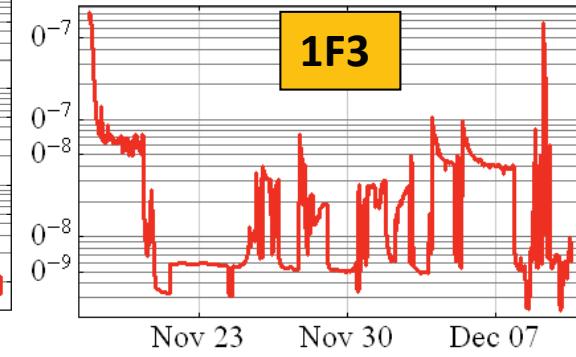
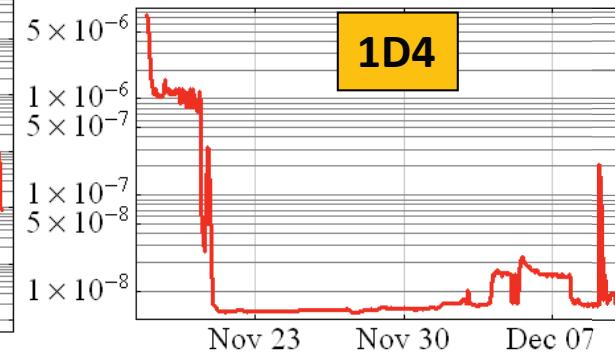
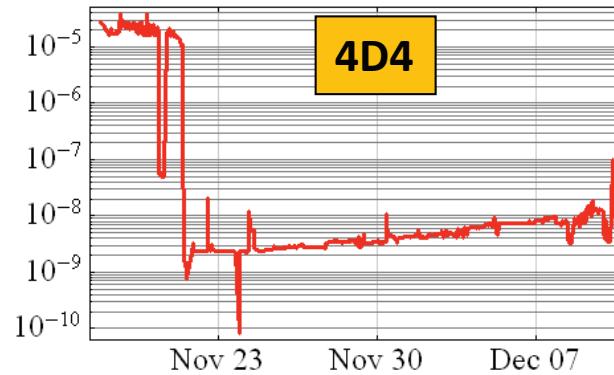
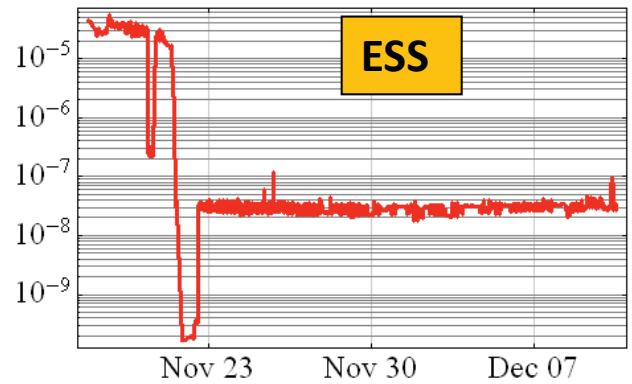
Vacuum systems of particle accelerators

Accelerator	Length, m	Pressure, Pa	Pump types	Status
LU-20	20	10^{-4}	Turbo pumps + cryopump	Upgraded
HILAC	11,5	10^{-5}	Turbo pumps + ion pumps	Assembled
Nuclotron	251,5	10^{-7}	Turbo pumps + ion pumps	Upgraded
Booster	211	10^{-9}	Ion pumps + getters	Production Assembling
Collider	503	10^{-9}	Ion pumps + getters	Design Production

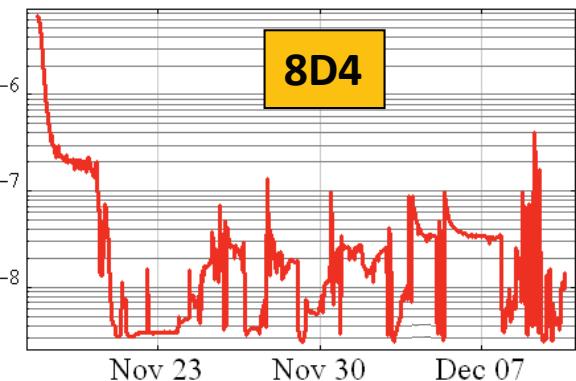
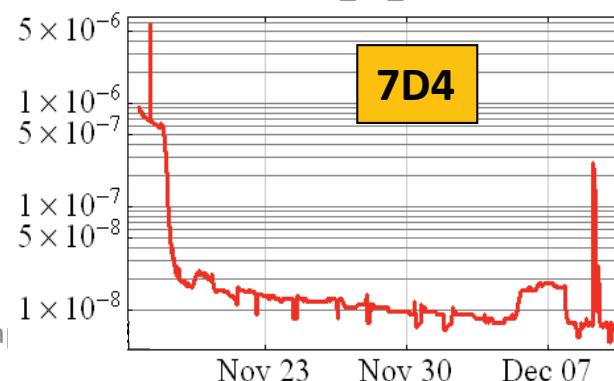
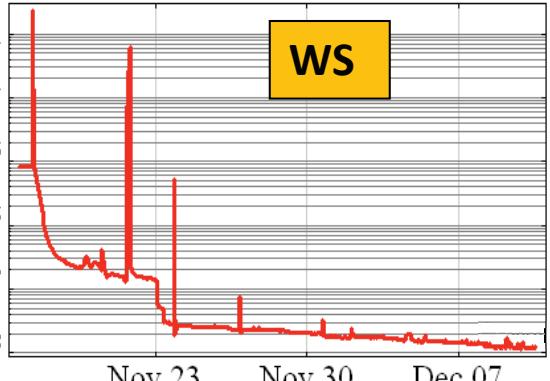
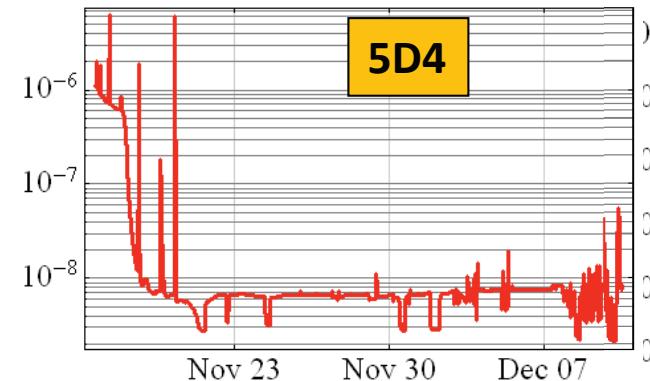


**Mass analyzer
QUADERA**

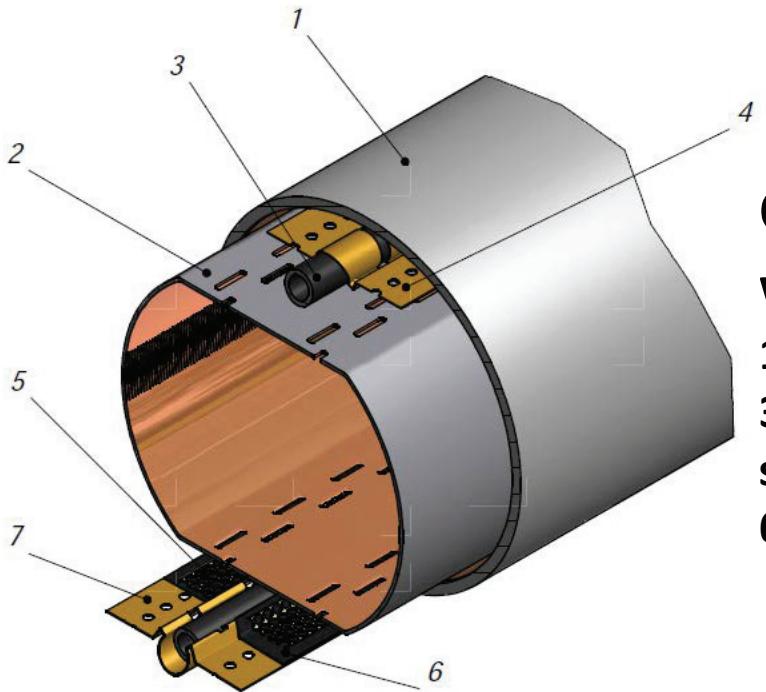
Nuclotron run for one month on 2009 (circumference 251 m)



INJECTION

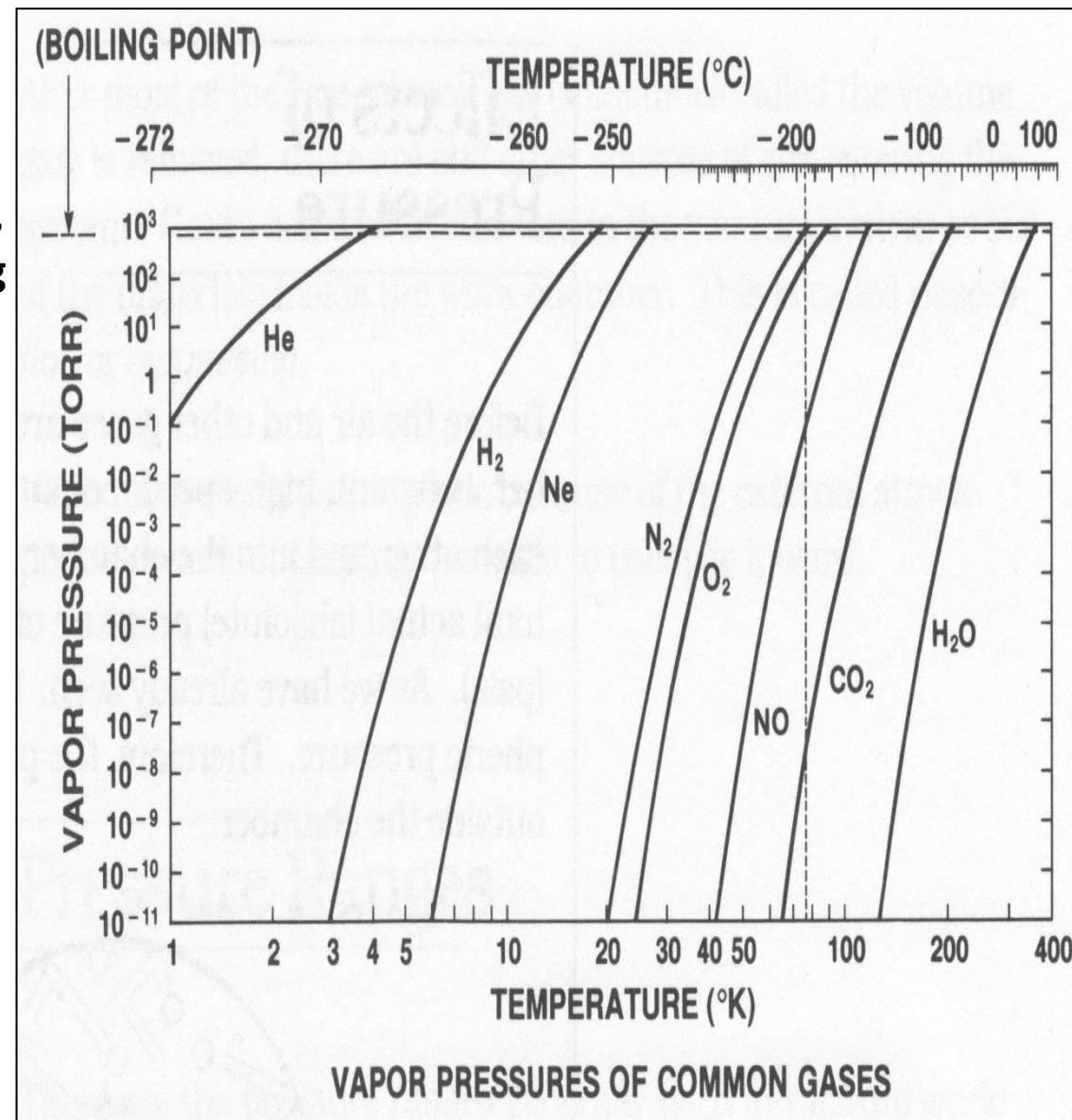
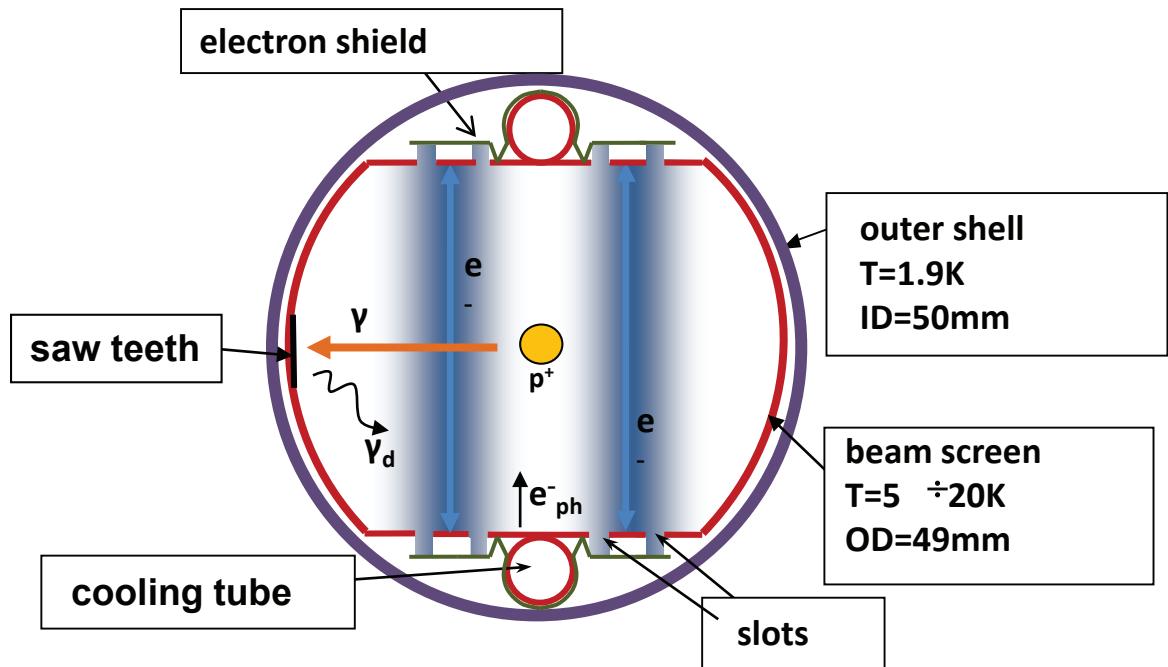


LHC vacuum chamber



Cold vacuum chamber with cryosorber

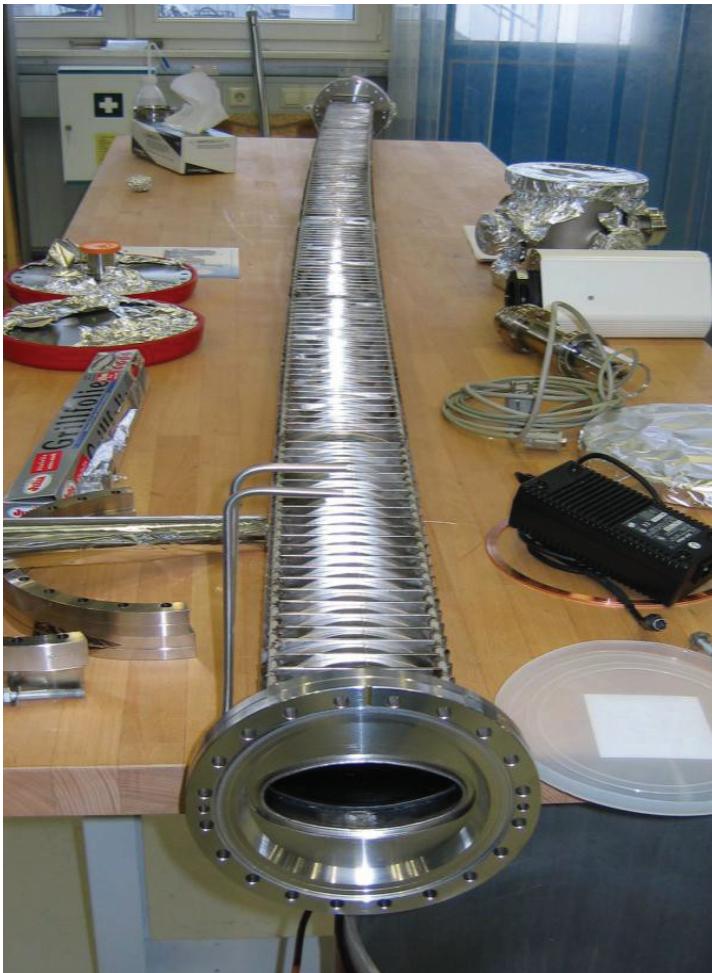
1 - outer shell, 2 – beam screen,
3 – cooling tube, 4,7 – pumping
slot shield, 5 – charcoal fiber,
6 – grid for charcoal fixing



SIS100 Dipole Chamber Design

Vacuum physical requirements on the magnet chamber design

- all dipole chambers represent 45% of the total cold surface in the cryogenic arcs
- the inner beam pipe wall will be used as expanded cold surface of an efficient cryopump with practically infinite capacity for nearly all condensable gas species wall temperatures as low as possible
- static vacuum pressure inside the chamber 10^{-12} mbar, under dynamic conditions $< 10^{-11}$ mbar
- due to the fast magnet ramping eddy currents heat up the chamber wall to temperatures $> 20K$



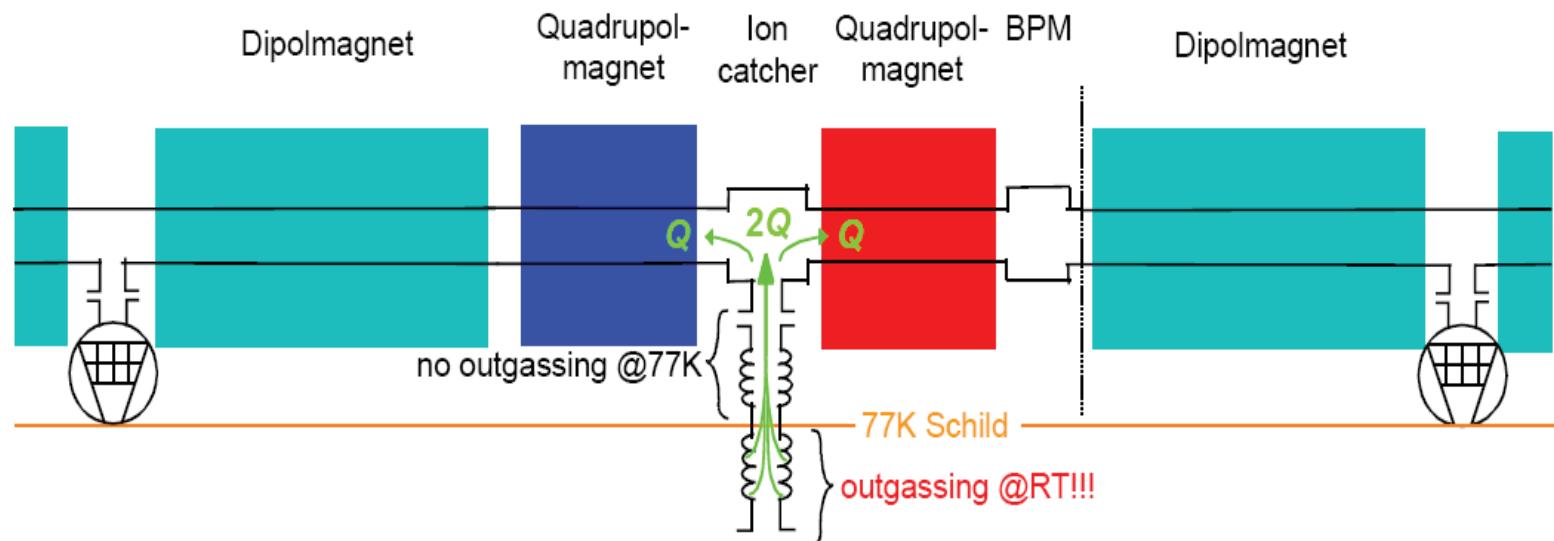
Length of chamber: 3.35 m

Aperture: 120 x 60mm²

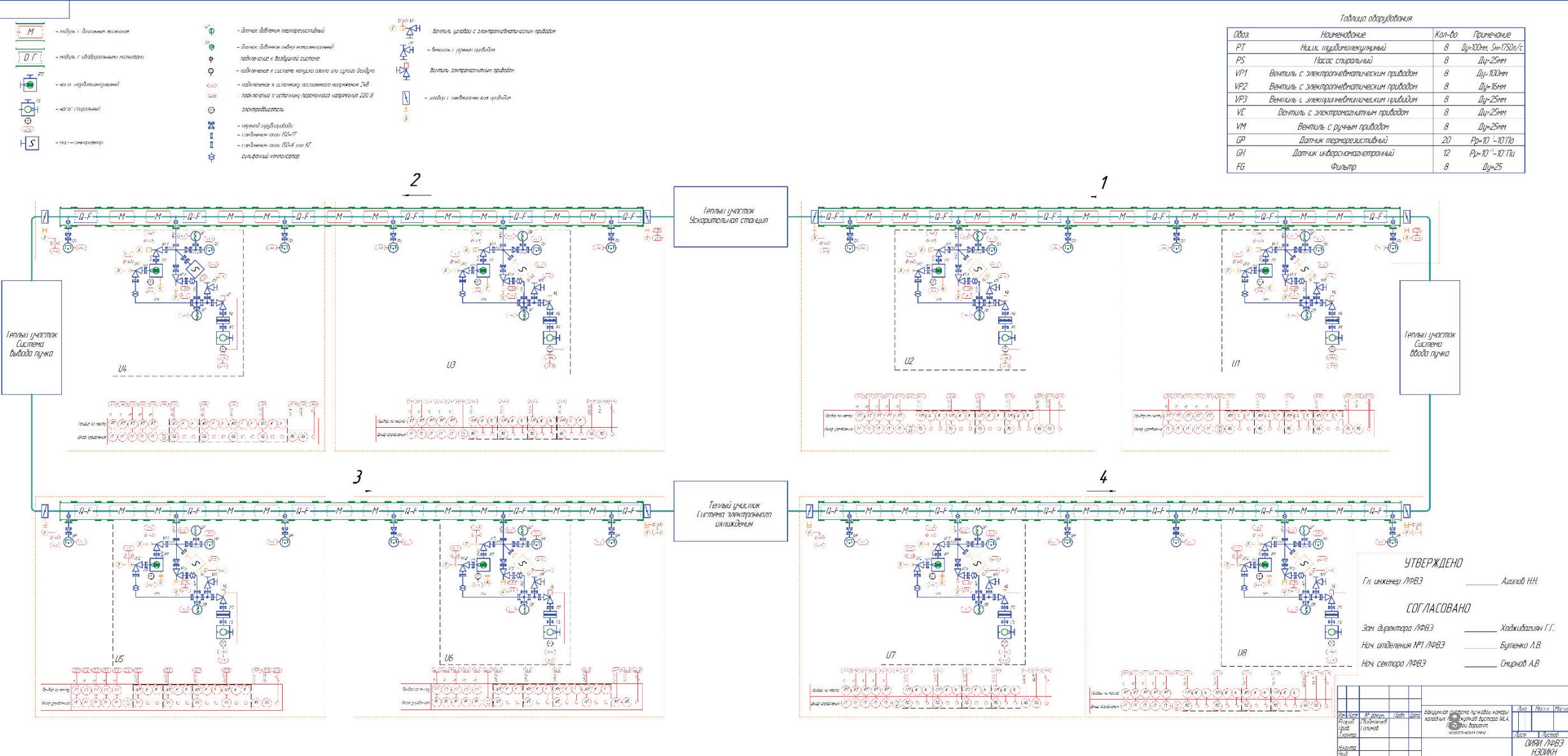
Wall thickness: 0.3mm

Rib thickness: 3.0 mm

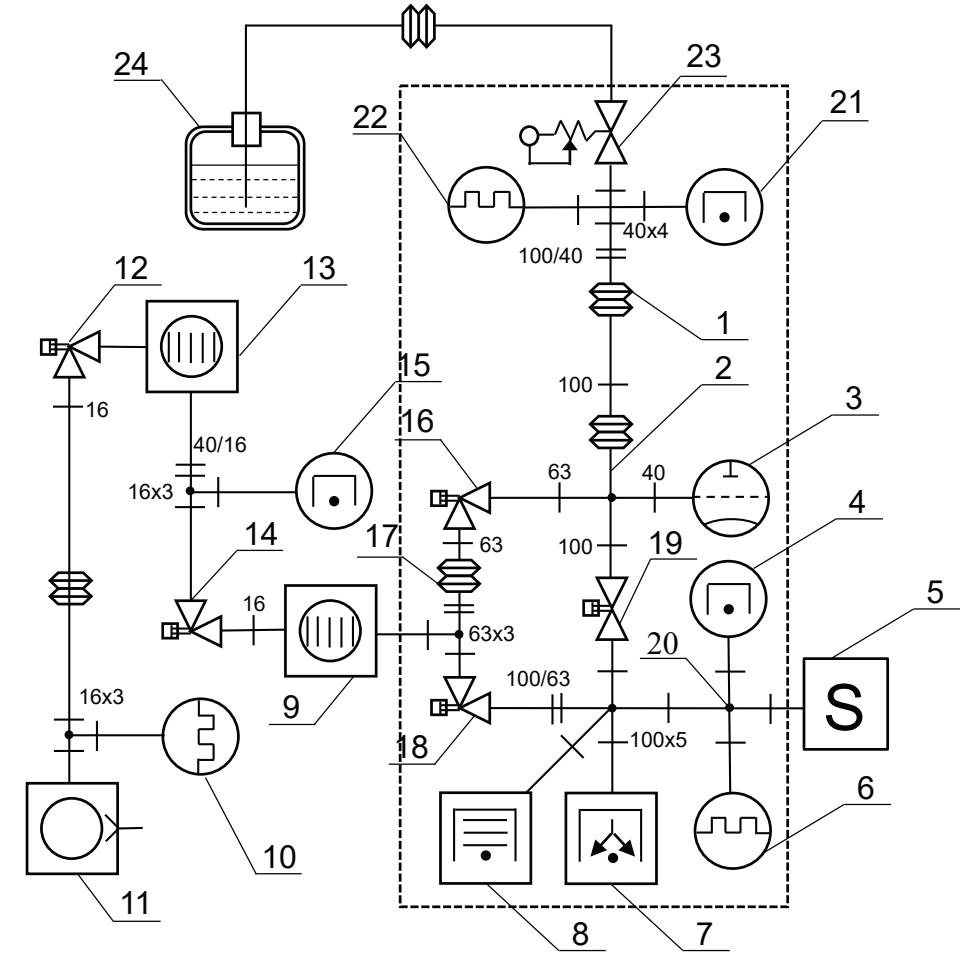
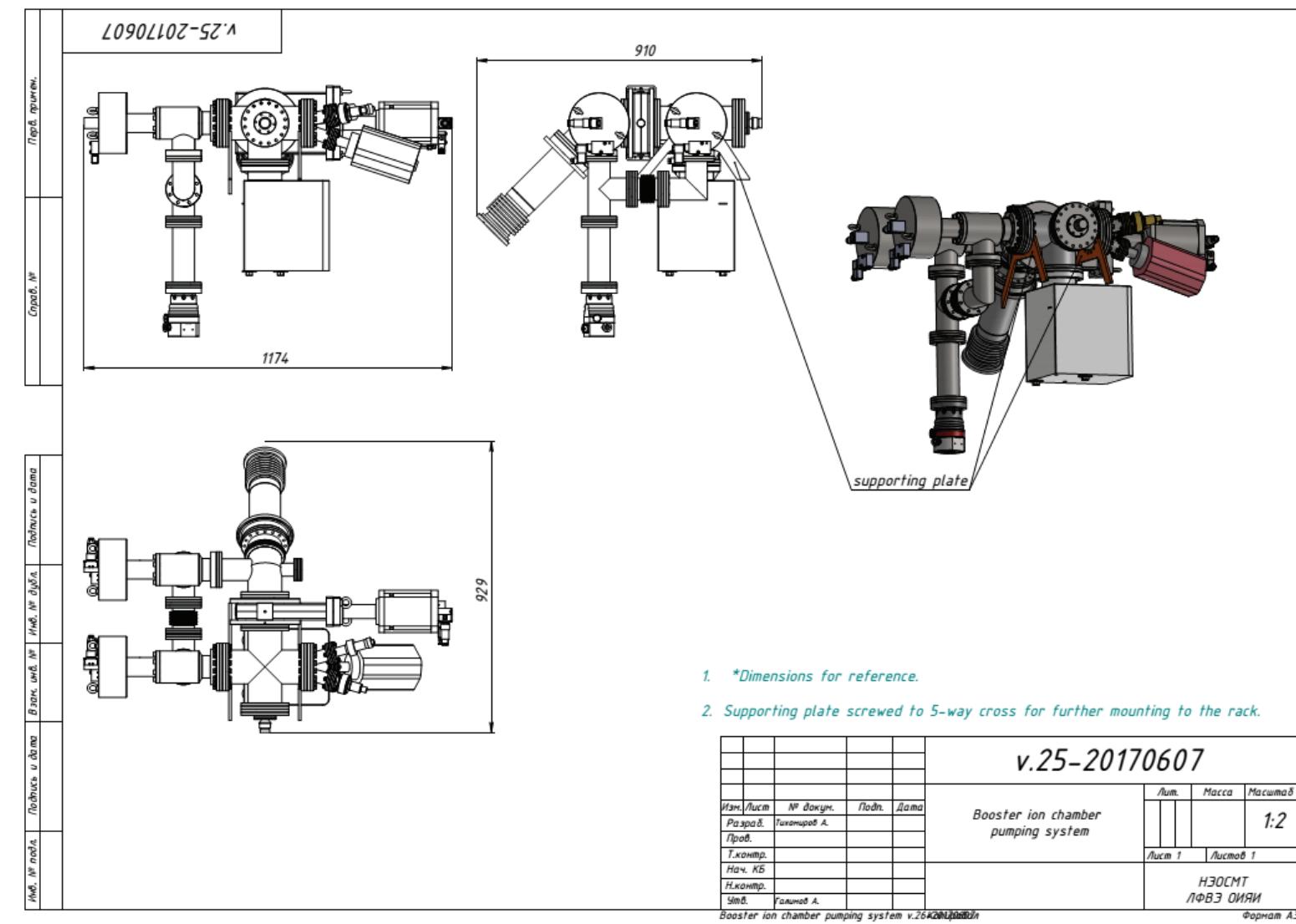
Cryosorption Pumps



Vacuum scheme for booster cold arcs (presented in poster)

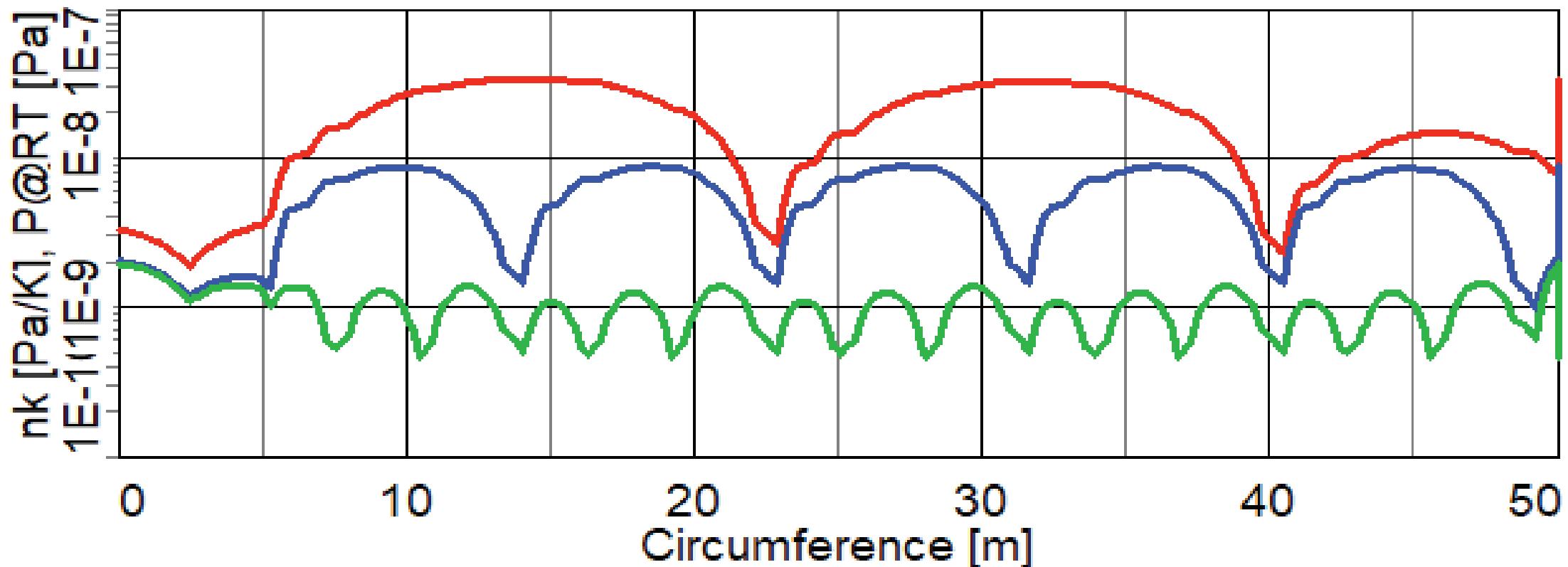


Prototype of vacuum stand (Vakuum Praha test)

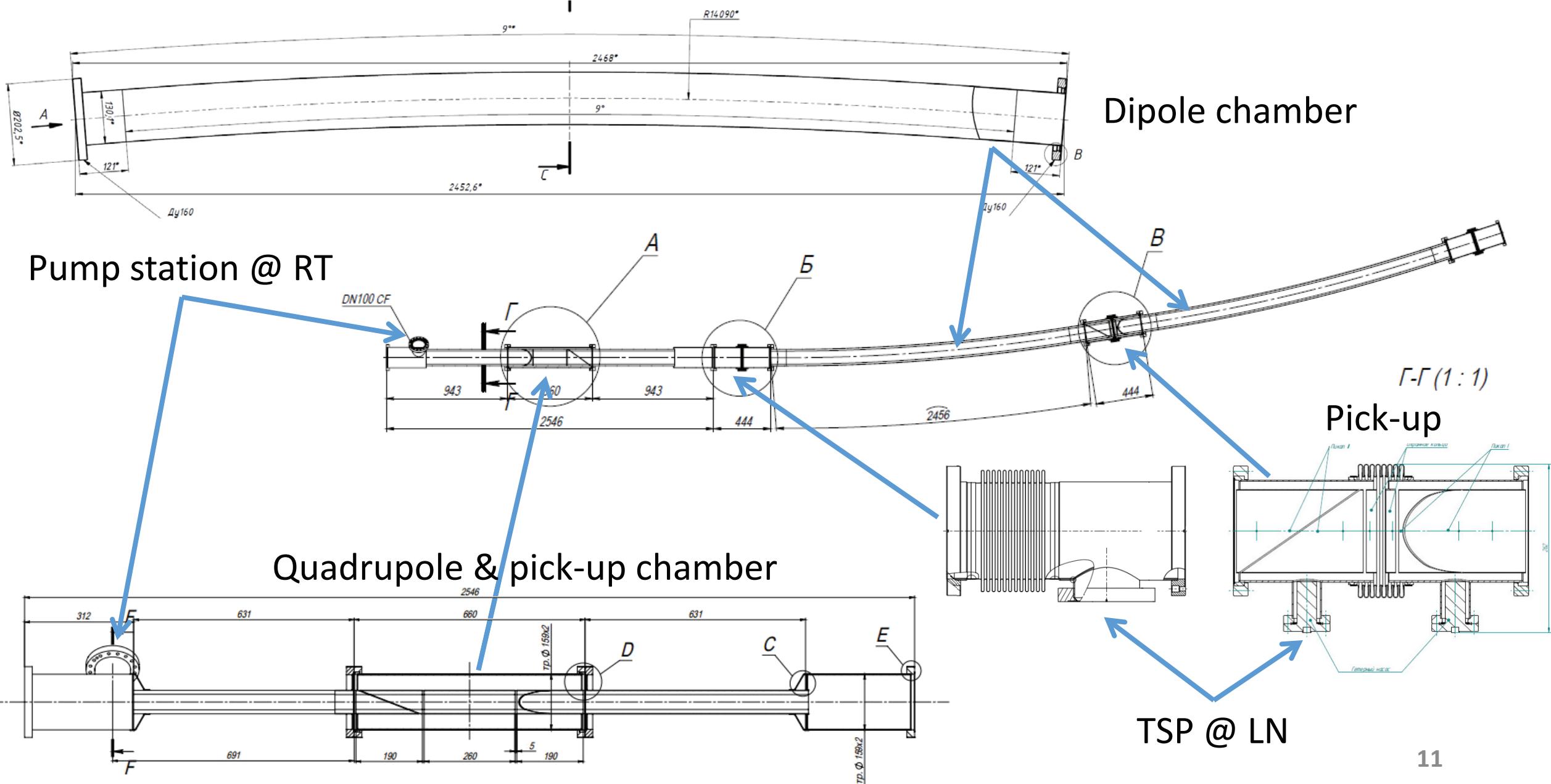


Simulation of dynamics vacuum and pressure distribution for $\frac{1}{4}$ booster (all gauges at room temperature)

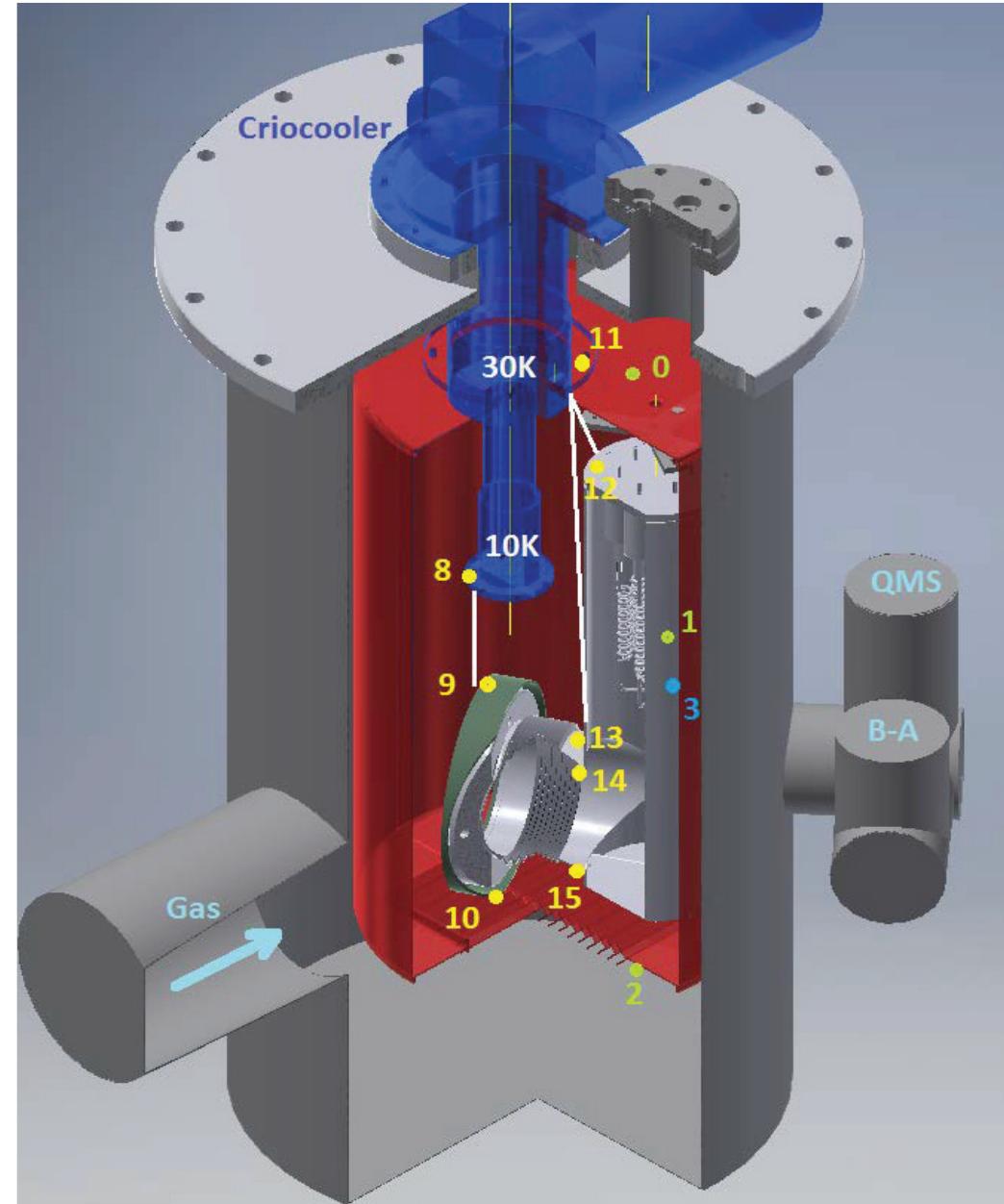
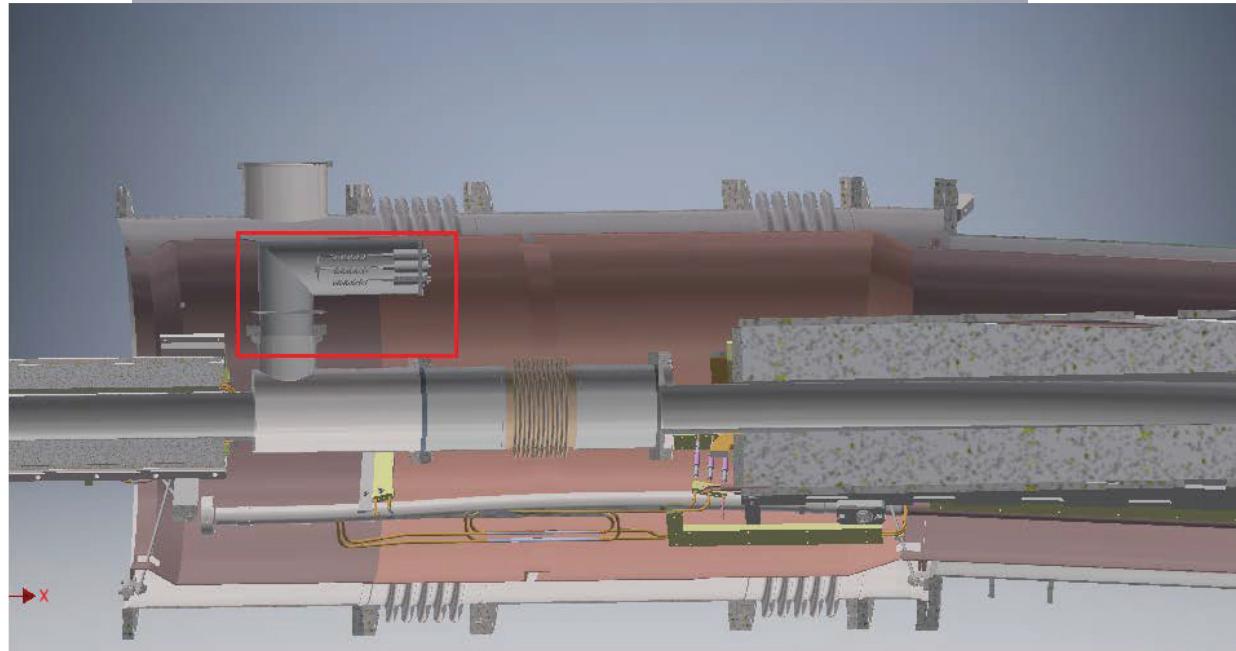
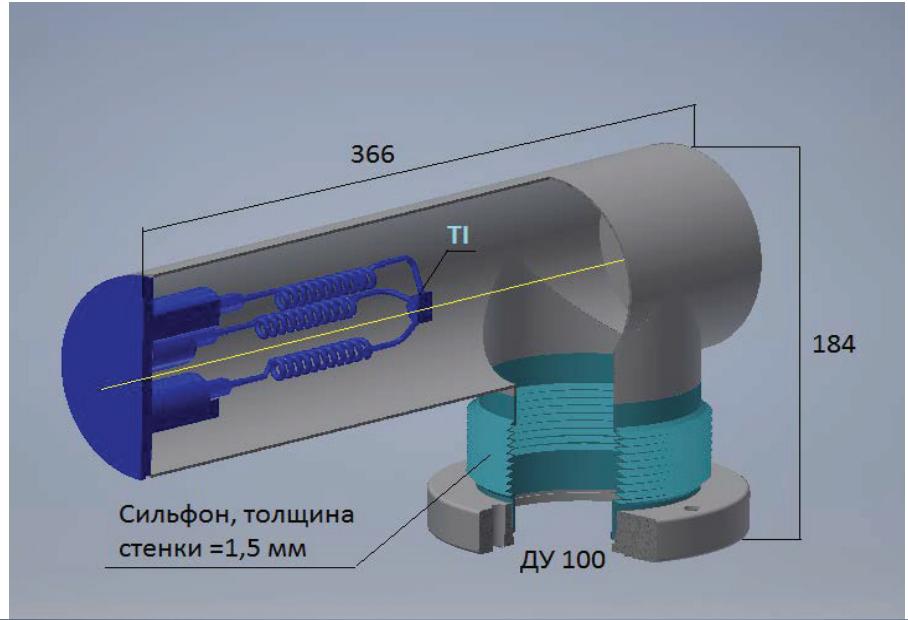
- 1) Red line – startup vacuum scheme (turbopumps only)
- 2) Blue line – normal vacuum scheme (ion pumps + TSP getters)
- 3) Green line - with additional TSP@LN between magnets



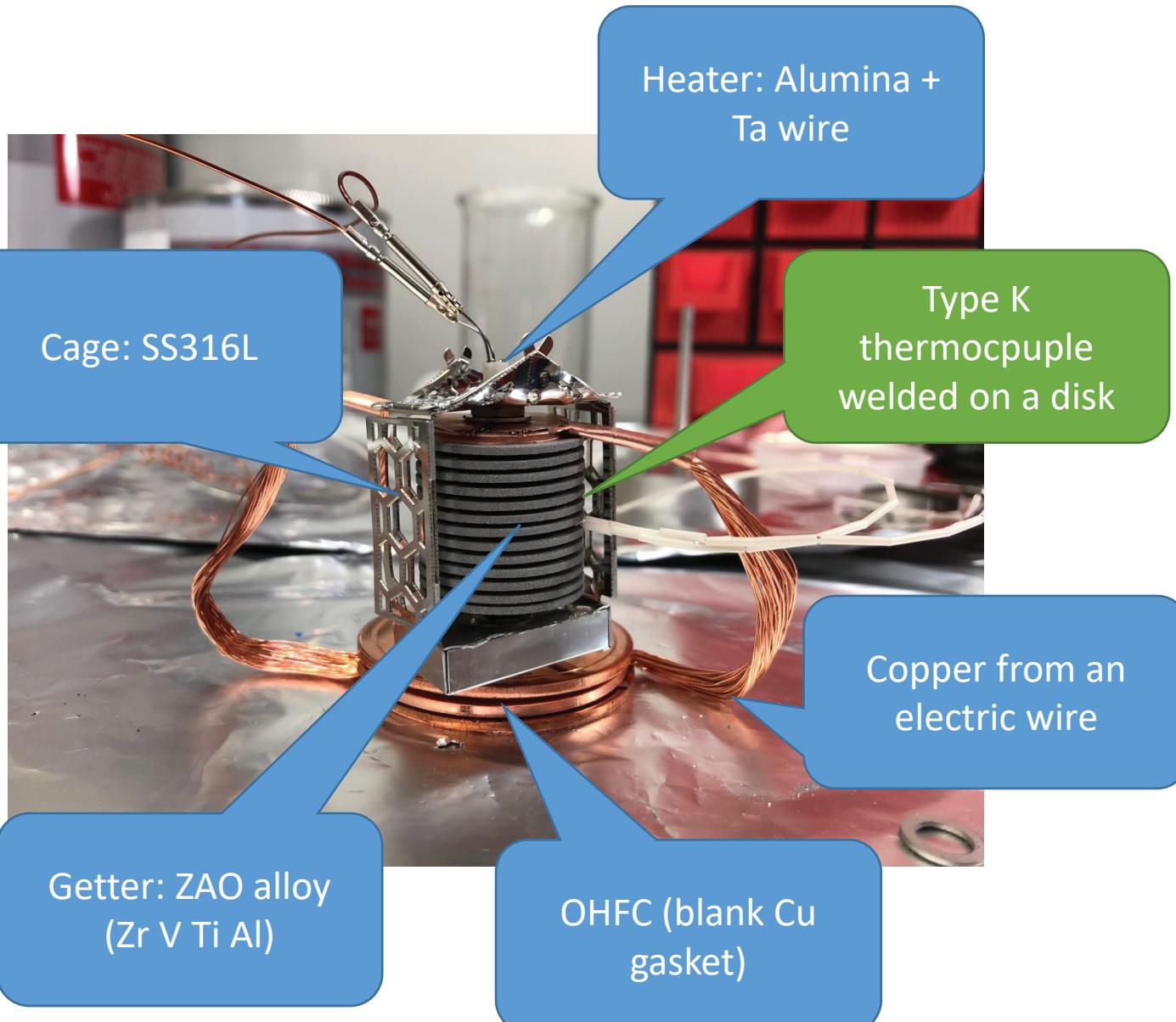
Booster vacuum chambers of cold arcs (FRAKOTERM)



TSP @ LN (BINP test)



NEG pump @ LN (SAES test)

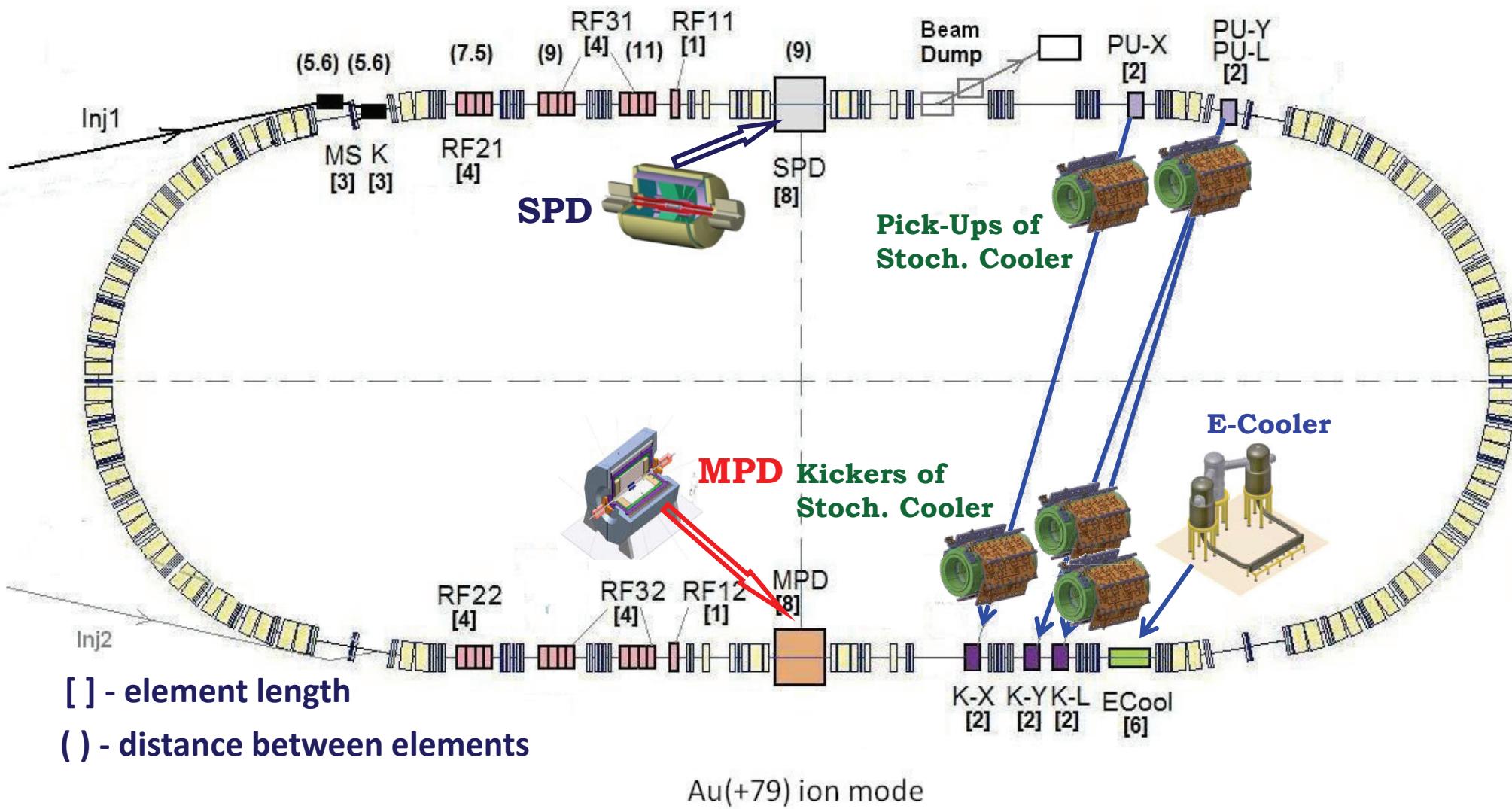


Status of booster vacuum systems

Name	Status	Chamber manufacturer	Pumping systems *
SC magnets	Assembling	FRAKOTERM, Poland	Ion pump + TSP
Pick-up stations	Production	FMB, Germany	
1) Injection septum	Production	Cryosystems, Moscow	Ion pump, TSP, NEG, CT
2) RF-stations	Under test at JINR	BINP, Novosibirsk	Ion pump + TSP
Pumping post		MILLAB, Moscow	
3) Extraction system + Channel to Nuclotron	Production	BINP, Novosibirsk	Ion pump + TSP
4) Electron cooling system	Assembled at JINR	BINP, Novosibirsk	Ion pump, TSP, NEG

* TSP – titanium sublimation pump, LN – temperature of liquid nitrogen
 CT – cryogenic trap, NEG – non-evaporated getter

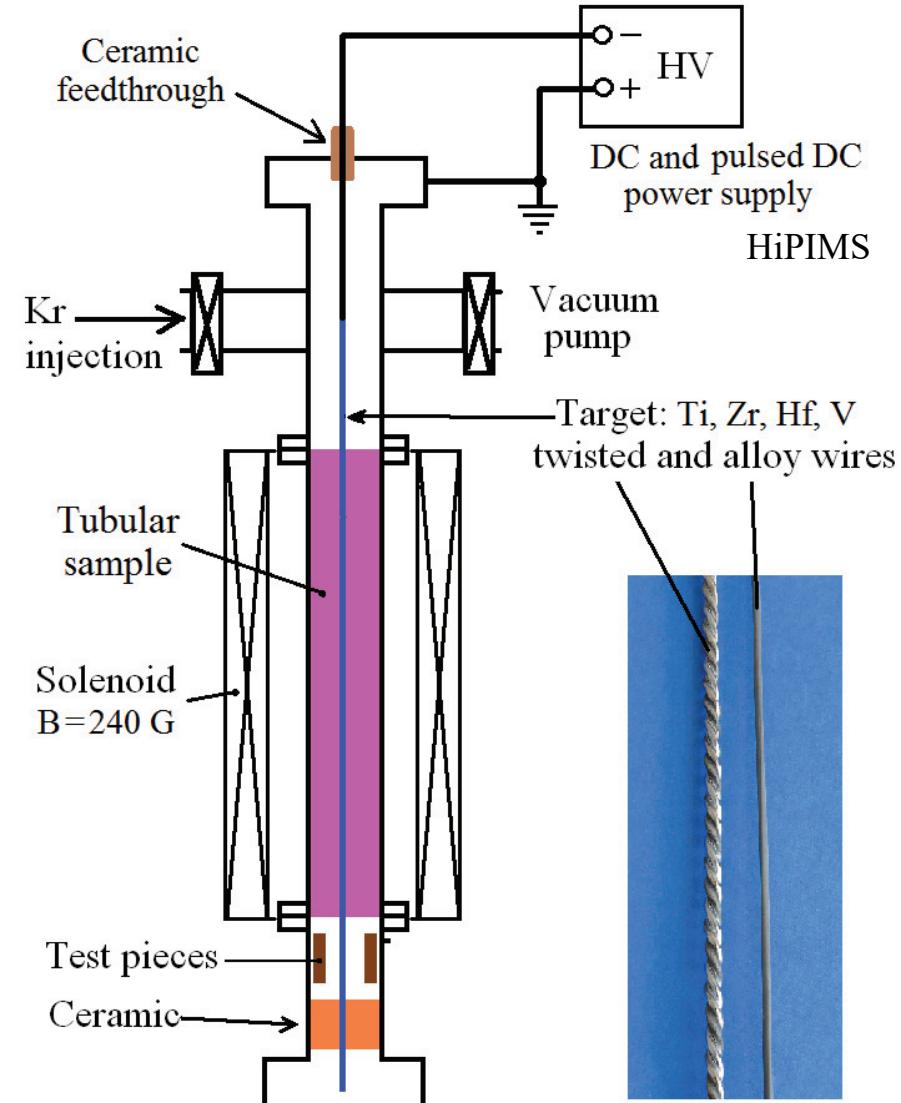
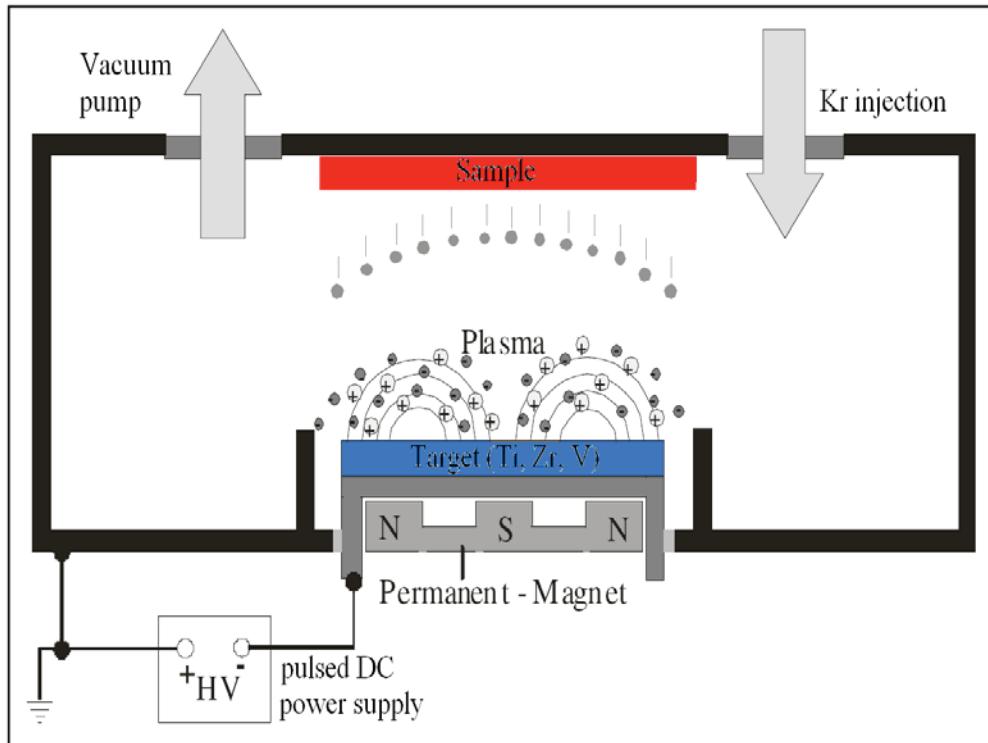
Configuration of the Collider for Heavy Ion mode



NEG coating technology

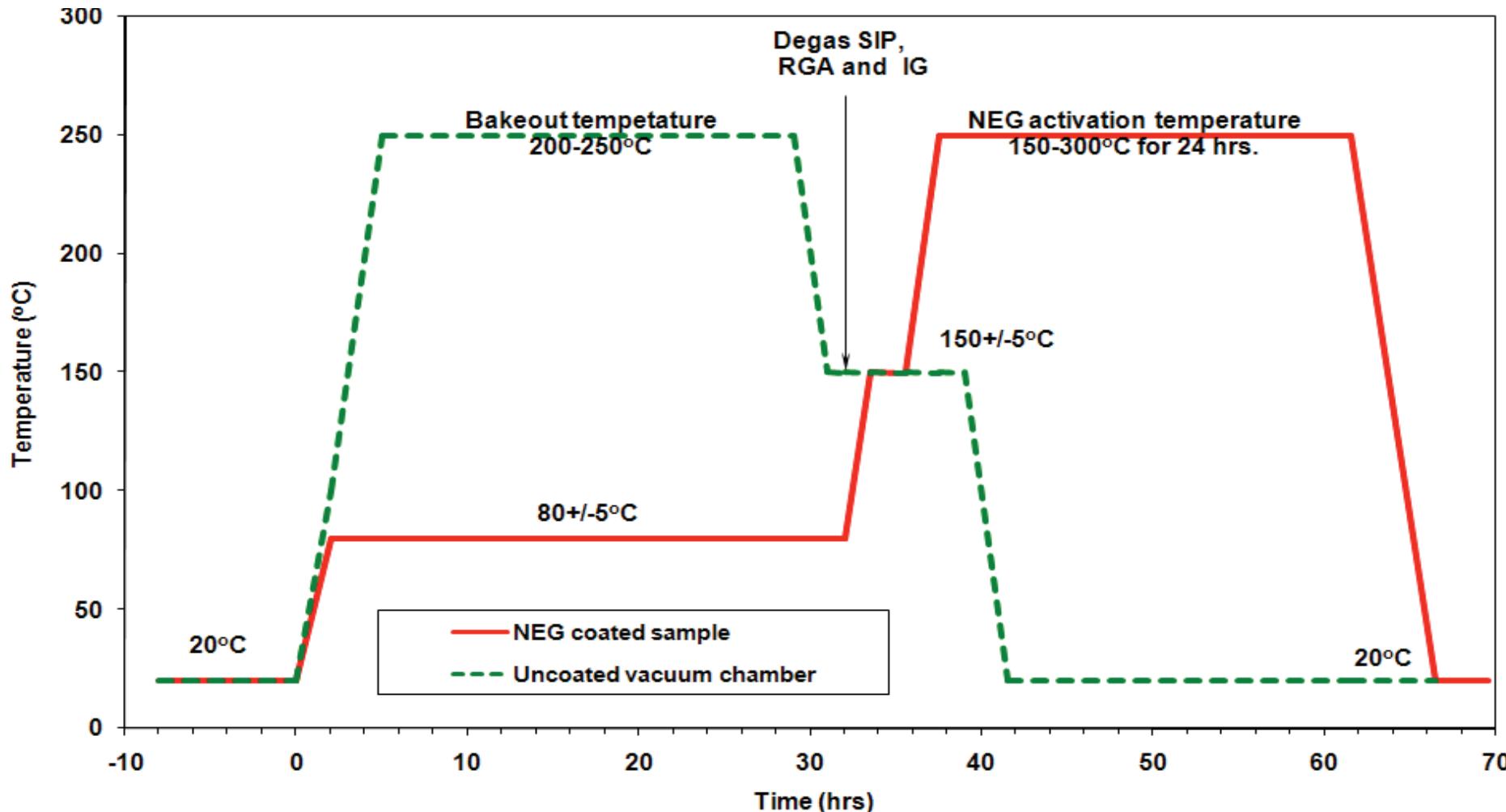
Cylindrical magnetron deposition for vacuum chambers

Commonly used planar magnetron deposition

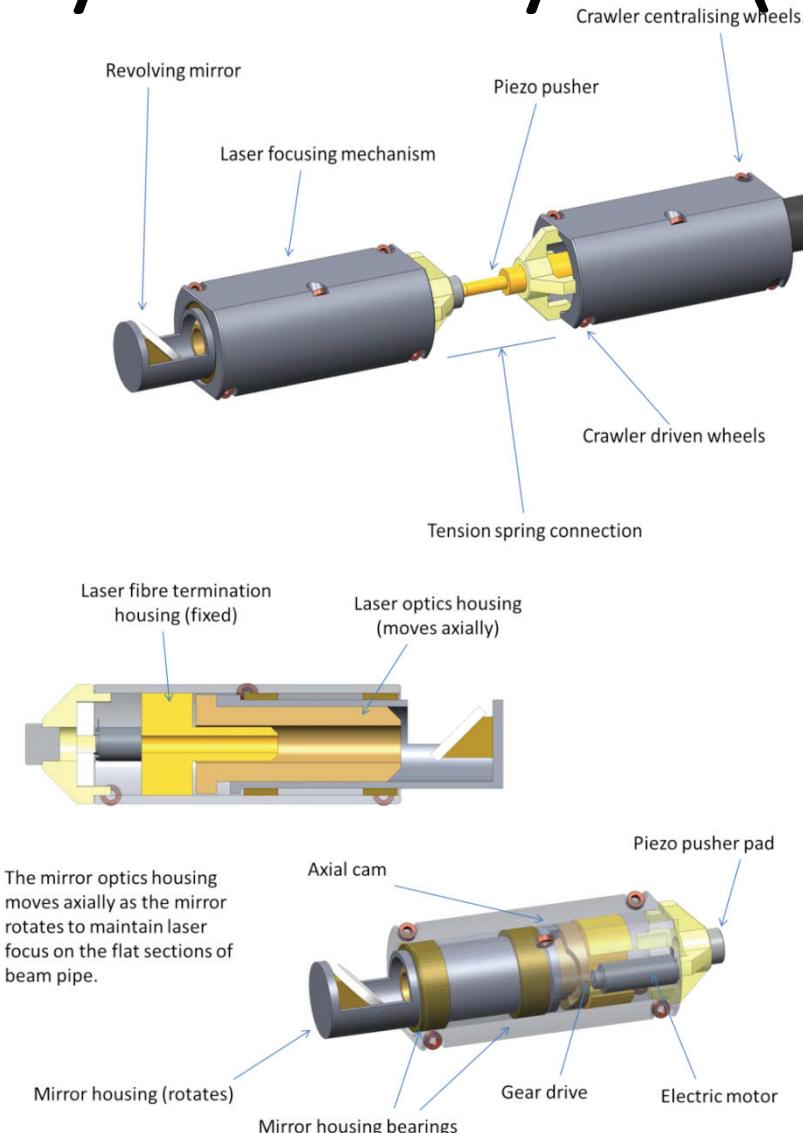
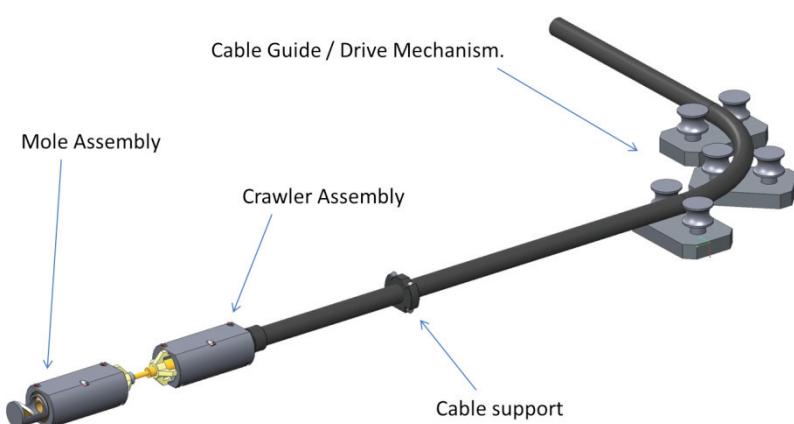
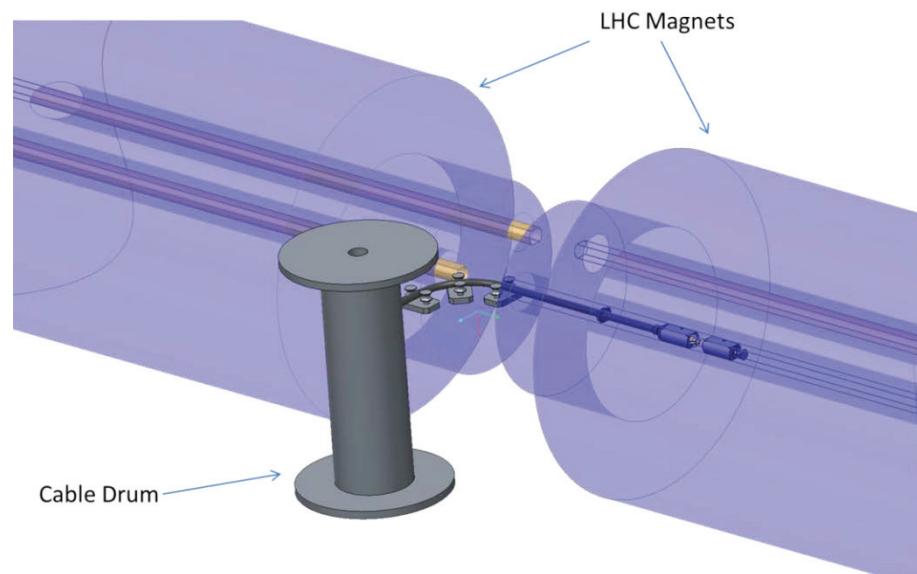


ASTeC activation procedure

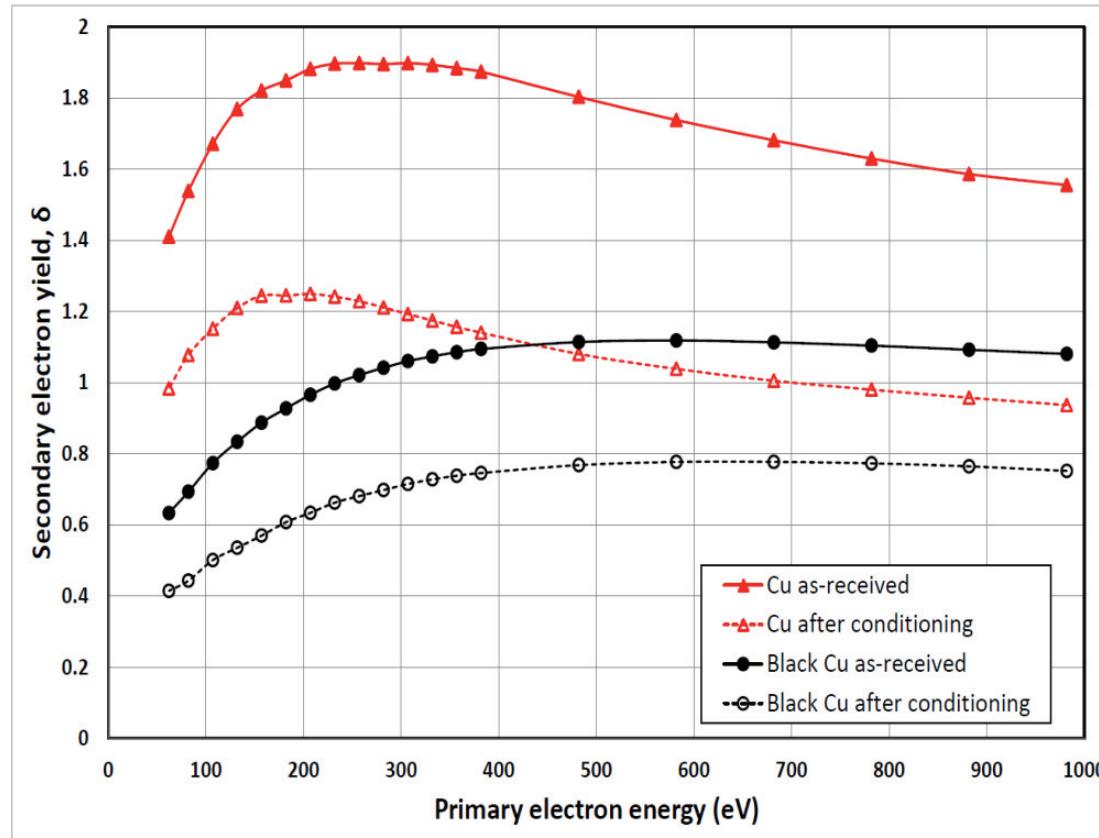
First procedure of the NEG coating is well-known as *CERN activation procedure*.
New procedure is named as ASTeC activation procedure (Accelerator Science and Technology Centre, STFC Daresbury Laboratory, Warrington, Cheshire, UK)



Laser technology for surface treatment to decreasing of secondary electron yield (SEY)



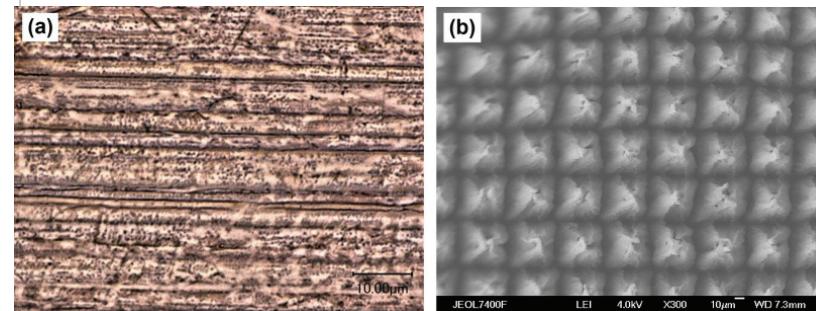
SEY of Cu as a function of incident electron energy



For Copper

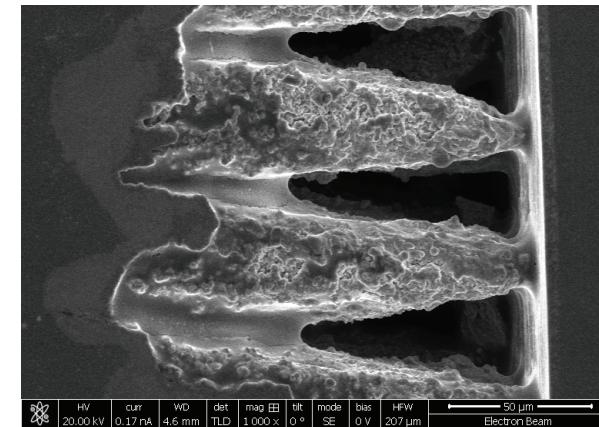
Nd:YVO₄ Laser

- Max Average Power = 10 W at $\lambda = 532$ nm
- Pulse length = 12 ns at Repetition Rate = 30 kHz
- Argon or air atmosphere
- Beam Raster scanned in both horizontal and vertical direction

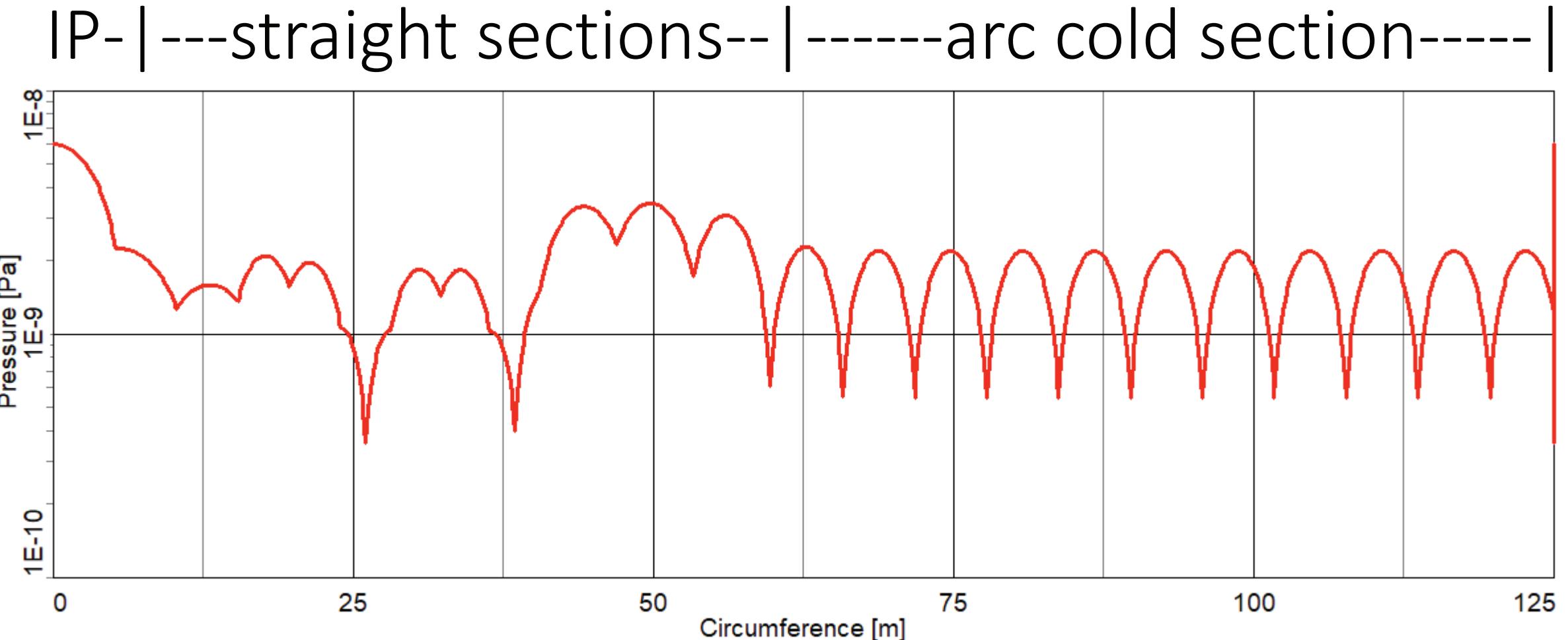


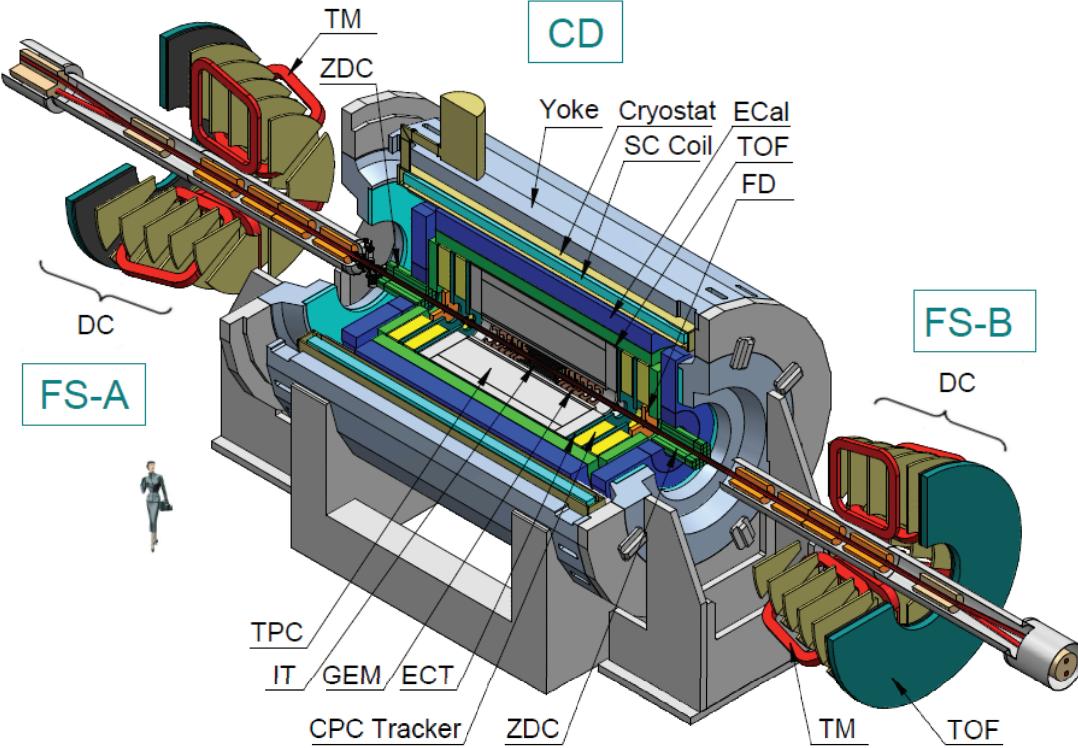
Untreated

Laser treated



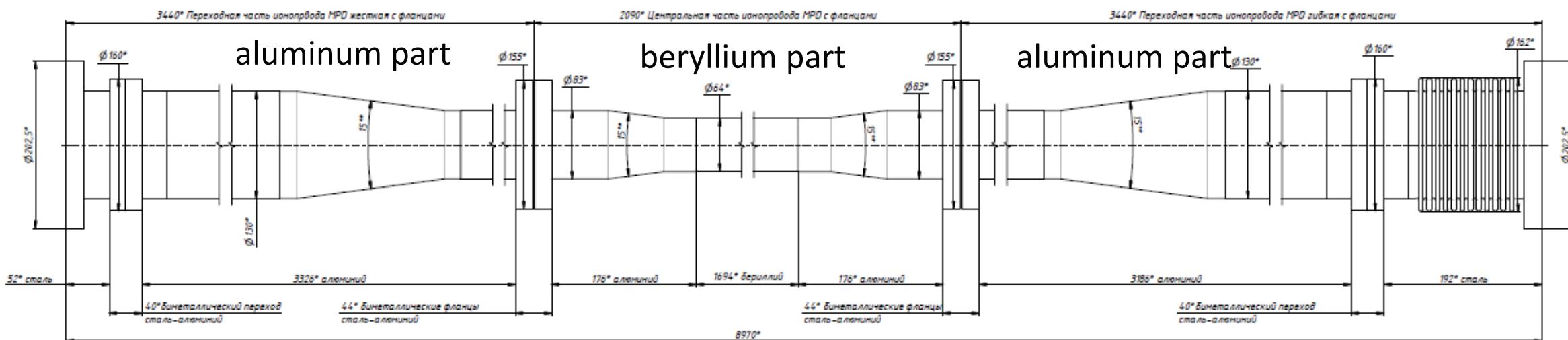
Simulation of pressure distribution (1/4 of collider)





Multi Purpose Detector

Beryllium (TB56) insertion
 («Kompozit», Korolev) +
 Aluminum alloy (AW-2219)



Status of collider vacuum systems

Name	Status	Chamber manufacturer	Pumping systems *
SC magnets	Production	FRAKOTERM, Poland	Ion pump + TSP
Injection channels	Production	SigmaPhi, France	Ion pump, TSP, NEG
RF-stations	Production	BINP, Novosibirsk	Ion pump + TSP
Electron cooling system	Production	BINP, Novosibirsk	Ion pump, TSP, NEG
Stochastic cooling	Design	FZJ, Juelich, Germany	Ion pump, TSP
MPD	Design	Kompozit, Korolev SDB IRE RAS, Fryazino	Ion pump, TSP, NEG

* TSP – titanium sublimation pump, LN – temperature of liquid nitrogen
 CT – cryogenic trap, NEG – non-evaporated getter